

Overall Assistance for Startup Immigration System (OASIS)
Recruitment of Participants for 2026 OASIS-3
(Intellectual Property Application Support) – 1st Cohort

KMAC Global Start-up Immigration Center

The **Overall Assistance for Startup Immigration System (OASIS)** is a program operated by **Global Start-up Immigration Centers** jointly designated by the **Ministry of Justice** and the **Ministry of SMEs and Startups of the Republic of Korea**, with the aim of promoting domestic startup activities by foreign entrepreneurs with outstanding technological capabilities.

The **Intellectual Property Application Support (OASIS-3)** is organized by the **Global Startup Immigration Center operated by Korea Management Association Consultants Inc. (KMAC)**.

□ *This program is not an educational program, but a 1:1 matching support program with a patent attorney or a patent law firm.*

A. Program Overview

1. Program:

Intellectual Property Application Support (OASIS-3), 1st Cohort

2. Objective:

To provide customized support across the entire patent, utility model, and design application process for participants with creative and commercially promising ideas, selected from outstanding graduates of the IP literacy courses (OASIS-1 & 2).

※ *Copyright and trademarks are excluded from support.*

3. Eligibility:

Graduates of the OASIS-1 and OASIS-2 programs who are legally residing in Korea, intend to establish a technology-based startup in Korea, possess creative and innovative business ideas, and plan to apply for intellectual property rights in Korea.

4. Application Period:

July 09 (Thu), 2026 – July 19 (Sun), 2026, until 24:00 (KST)

5. Application Method:

Submission of required documents via email:

- (1) IP-specific Application Form (including attachments, if applicable),
- (2) Participation Application Form,
- (3) Sworn Statement Form,
- (4) Proofs of Immigration/Residency Status
- (5) OASIS-1 & OASIS-2 Completion Certifications.

6. Recruitment Size:

Approximately 15 participants

7. Screening Period:

July 20 (Mon) – July 29 (Wed), 2026

8. Screening Method:

Document screening

※ *Different screening criteria and required documents apply to each of the three IP fields.*

9. Final Selection:

July 30 (Thu), 2026

10. Benefits of Participation:

- 1:1 patent application consulting with a patent attorney (two sessions)
 - Prior art search support
- Partial support for application filing costs (one application per participant), subject to the available budget.

B. Support Details

- 1:1 patent application consulting with a patent attorney (two sessions per participant)
 - Prior art search support
- Financial support covering up to 50% of intellectual property (patent, utility model, or design) application filing costs, subject to the available budget. Support is limited to one application per participant.

☐ Support Scope by IP Type

Field	Scope of Support(per person)
Patent filing	Up to KRW 2,000,000
Utility Model filing	Up to KRW 1,300,000
Design filing	Up to KRW 700,000

Important Notes:

- *Financial support is provided on a reimbursement basis rather than as an advance payment.*
- *Only participants who successfully complete the intellectual property application filing are eligible for reimbursement of up to 50% of the application costs, subject to the program's funding limit. Reimbursement will be based on the actual expenses incurred.*
- *After completing the application filing, participants must submit the required supporting documents, including proof of the application filing and payment receipts. The reimbursement amount will be determined after the submitted documents have been reviewed and approved.*

C. Process & Schedule

Step	Process	Schedule
1	Application submission	Jul 09 (Thu) – Jul 19 (Sun)
2	Document screening	Jul 20 (Mon) – Jul 29 (Wed)
3	Final Selection & Result Announcement	Jul 30 (Thu)
4	Orientation	Aug 04 (Tue)
5	1:1 Consultation	1st : During the 1st week of August
		2nd: During the 2nd week of August
6	Filing via partner patent firm	3rd week of August – 2nd week of September

Important Notes:

- *Consultations are conducted one-on-one with a patent attorney (60 minutes per person), and detailed schedules will be provided individually to selected participants.*
- *The orientation will be conducted online. Participants who do not attend the orientation will be disqualified from the program.*
- *Detailed schedules and program information will be provided individually to selected participants.*

D. Application Method

1. Required Documents:

- (1) IP-specific Application Form (including attachments, if applicable)
- (2) (Form 1) OASIS Application Form
- (3) (Form 2) OASIS Sworn Statement Form
- (4) Proofs of Immigration/Residency Status (A Copy of Alien Registration Card, etc.)
- (5) OASIS-1 & OASIS-2 Completion Certification

※ The required application form differs by field (Patent / Utility Model / Design), so please check carefully when applying.

2. Submission Method:

Submit all required documents via email to the Global Startup Immigration Center

Email: oasis@kmac.co.kr

3. Email Subject Line:

Submission of Application Documents for OASIS-3 (1st Cohort) (Applicant's Name)

※ Participants will be selected through eligibility verification and document screening.

※ Final selection results will be individually notified via email on July 30 (Thu).

E. Inquiry: Global Start-up Immigration Center

- Tel: 02-2135-3380
- Email: oasis@kmac.co.kr
- Address: Global Startup Immigration Center
(3rd Floor, Goryeo Building, 76 Keunumul-ro, Mapo-gu, Seoul)